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2621

| David Walter Rose   | Date: 3 August 2004             |
|---|---------------------------------|
| Serial Number: 09/864,105                                     | Group Art Unit: 2621            |
| Filed: 23 May 2001  | Examiner:  LU, TOM Y            |
| Title:     "Surface-Profiling System and     Method Therefor" | Attorney Docket No:<br>1320-050 |

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Signature

3 August 2604
Date of Signature

**AMENDMENT** 

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**Technology Center 2600** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed 6 May 2004, please amend the above-referenced application as indicated herein.

Amendments to the Specification begin on page 2 of this paper.

A Listing of Claims begins on page 3 of this paper.

Remarks/Arguments begin on page 11 of this paper.